



PATENT  
790001-2042

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Naofumi NAKAMURA et al.  
U.S. Serial No. : 10/752,642  
Filing Date : January 7, 2004  
For : ***SEMICONDUCTOR DEVICE AND METHOD OF  
FABRICATING THE SAME***  
Group Art Unit : 2811

745 Fifth Avenue  
New York, New York 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 26, 2004.

Grace L. Pan, Reg. No. 39,440  
(Name of Applicant, Assignee or Registered Representative)

  
Signature

April 26, 2004  
Date of Signature

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Further to the Information Disclosure Statement filed on December 23, 2003, the Examiner's attention is respectfully invited to review the accompanying form PTO-1449 along with copy of the reference identified therein.

**FOREIGN PATENT DOCUMENTS**

1. Japanese Laid-Open Application No. 9-289214, Published: November 4, 1997.

(The specifics of this application are mentioned in the Specification at pp. 4-5).

**REMARKS**

This Information Disclosure Statement is being filed pursuant to 37 C.F.R. § 1.97(b)(3) and is not a representation that the document cited herein is considered most pertinent, or that a search has been undertaken, or that the cited document is indeed prior art. The Examiner is respectfully invited to undertake an independent search.


Applicants respectfully request that the Examiner consider and make of record the document cited herein and that a copy of Form PTO-1499, appropriately initialed by the Examiner be returned to Applicants' attorney.

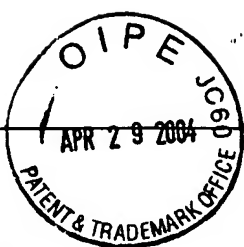
It is believed that no fee is due, however, the Commissioner is hereby authorized to charge any fee or credit any overpayment therein to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP  
Attorneys for Applicants

By:

  
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Based on Form PTO-1449  
(3/90)

ATTY. DOCKET NO.

790001-2042

SERIAL NO.

10/752,642

## SUPPLEMENTAL LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT

Naofumi NAKAMURA et al.

FILING DATE

January 7, 2004

GROUP

2811

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AA	9-289214	11/4/97	Japan				X*

## OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.